



International Online Plasma Seminar (IOPS)

Streamer discharge instabilities under repetitive nanosecond pulses

Zheng Zhao, Anbang Sun, Jiangtao Li

zhaozhengz@xjtu.edu.cn

School of Electrical Engineering Xi'an Jiaotong University, Xi'an, Shaanxi, China



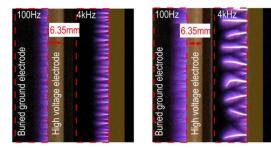
01 Background

- **02** Discharge instability coupled with pulsed power supply
- **03** Discharge instability affected by gas flow
- 04 Concluding remarks

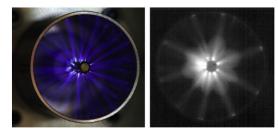
Background: Nanosecond repetitively pulsed discharge

Nanosecond repetitively pulsed (NRP) discharge plasma: high frequency pulses

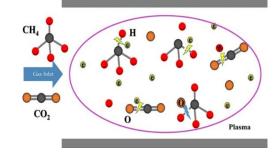
• Exclusive capabilities (overvoltage ratio) for non-equilibrium plasma-assisted applications



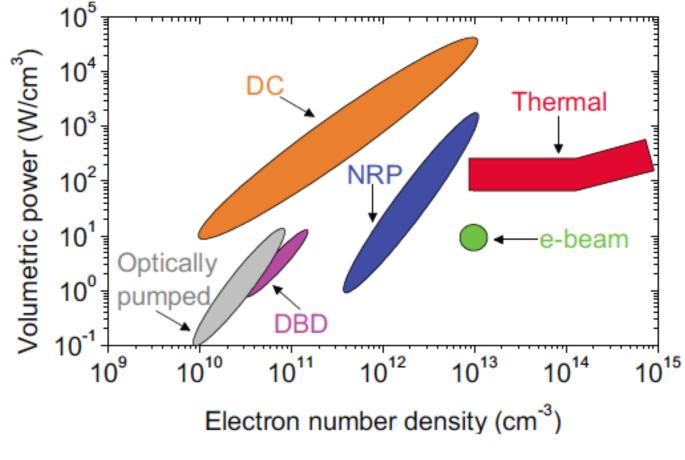
Surface DBD flow actuator



Plasma-assisted combustion



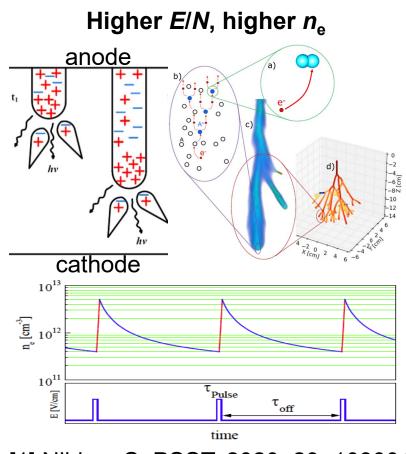
Methane dry reforming

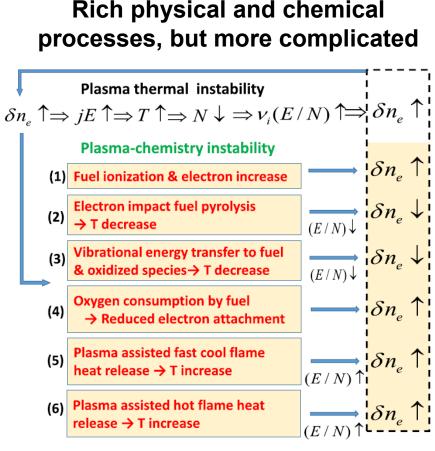


[1] Takashima, PSST, 2011, 20, 055009. [2] Wang, Applied Energy, 2019, 243: 132-144. [3] D. Rusterholtz, PhD thesis, 2012.

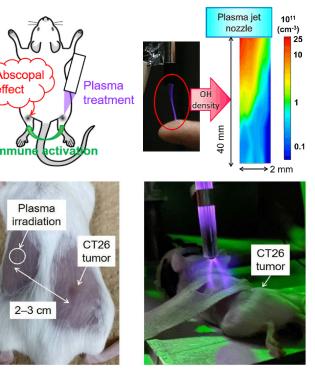
Background: Why we prefer NRP streamer discharge

Nanosecond repetitively pulsed streamer discharges have many advantages over conventional medium-frequency AC and microsecond pulse driven plasma!





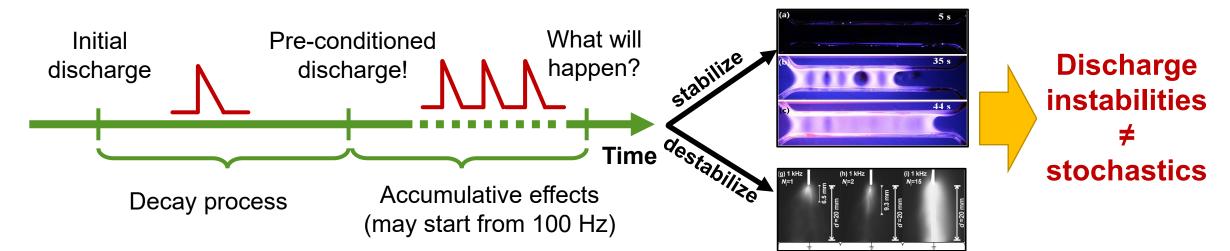




[1] Nijdam S, PSST, 2020, 29, 103001. [2] Rousso A, PSST, 2020, 29, 105012. [3] Jinno R, JPD, 2022, 55, 17LT01

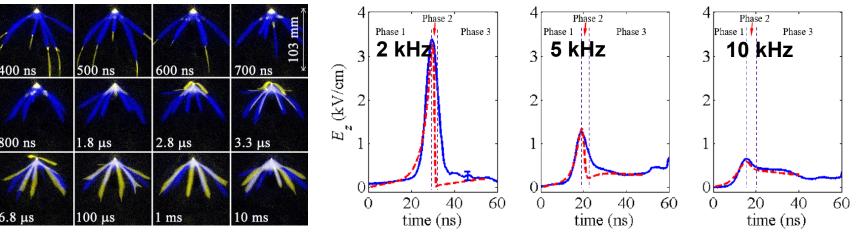
Background: NRP streamer discharge is "memorized"

Discharge evolutions under repetitive pulses (especially at high PRF!)



Memory effect agents with different influential mechanisms

- Metastable species
- Residual electrons
- Space charges
- Residual conductivity
- Surplus heat

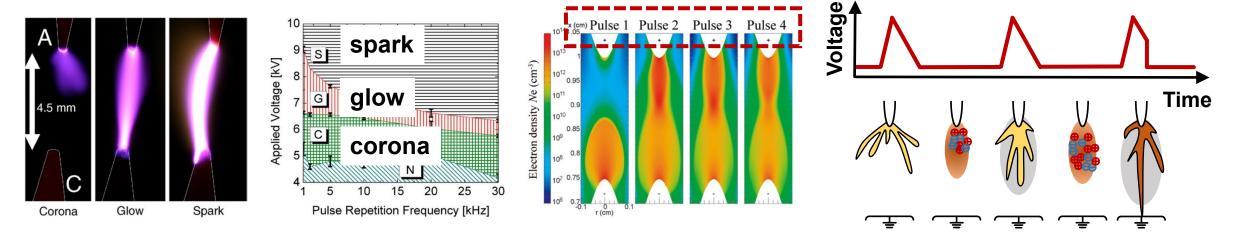


[1] Qi F, APL, 2019, 115, 194101. [2] Nijdam S, PSST, 2014, 23, 025008. [3] Huang B, JPD, 2018, 51, 225202. 5/33

Background: low-temperature plasma instabilities

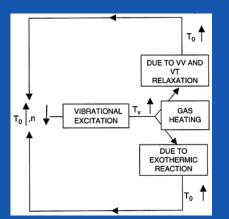
One instability example: NRP discharge regime transition

• Fundamental parameter, corona-glow-spark transition, voltage parameter dependences, "binary" operation



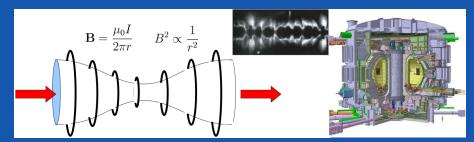
Low-temperature plasma instabilities

- Thermal-ionization instability
- Chemical reactions (e.g., exothermic reactions)
- Strong coupling with environment factors

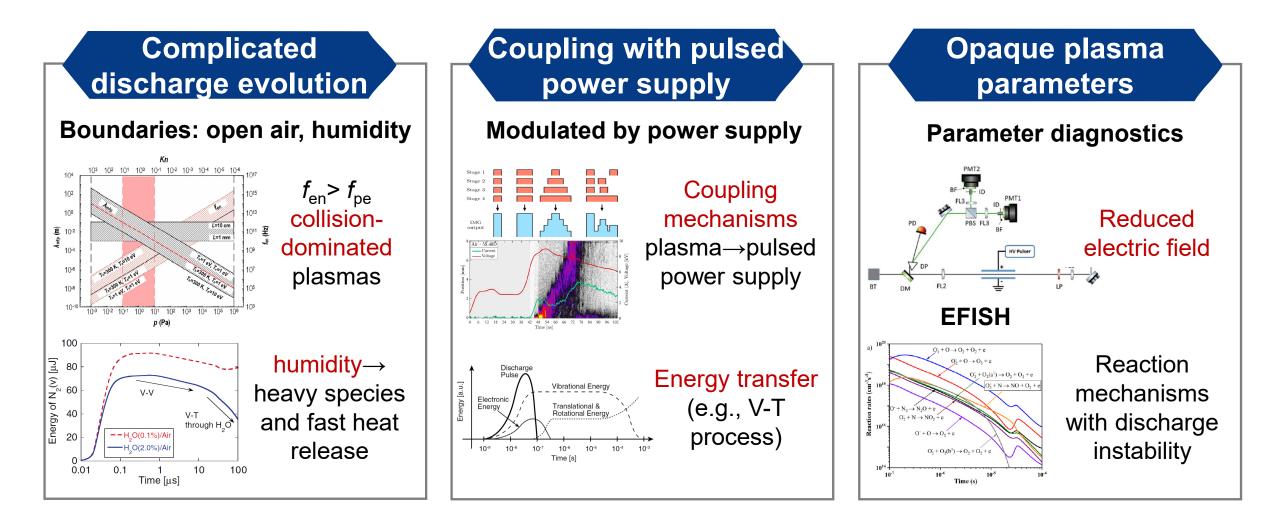


High-temperature plasma instabilities

- Drift wave instabilities
- Rayleigh-Taylor instability



Background: NRP streamer instabilities uniqueness



[1] Li H, Physics Reports, 2018, 770-772. [2] Komuro, PSST, JPD, 2014, 47, 155202.
[3] Huiskamp, JPD, 2022, 55, 024001. [4] Chng TL, Optics Letters, 2020, 45, 1942-1945

Motivations: NRP discharge instability and modulation

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Journal of Physics D: Applied Physics

https://doi.org/10.1088/1361-6463/ac5e1

Roadmap

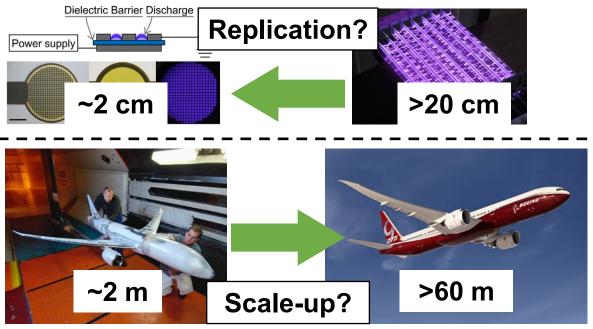
The 2022 Plasma Roadmap: low temperature plasma science and technology

The strong interaction with surfaces can lead to self-organizing behavior, most likely resulting from memory effects associated with surface charge patterns or streamer–streamer interactions. Control of such behavior to enable homogeneous surface treatment or exploit advantages of self-organized patterns for deliberate inhomogeneous treatments remain out of reach. This self-organization behavior and plasma instabilities at elevated pressures lead also to challenges for plasma source scale-up at atmospheric pressure as required for many emerging applications.

1. New plasma excitation and generation approaches

Nikolai Tarasenko¹ and Peter Bruggeman²

¹ Institute of Physics, Minsk, Belarus
 ² University of Minnesota, Minneapolis, United States of America



Scaled-down model

Scaled-up application

[1] B Boekema *et al* 2016 *JPD.* **49** 044001



01) Background

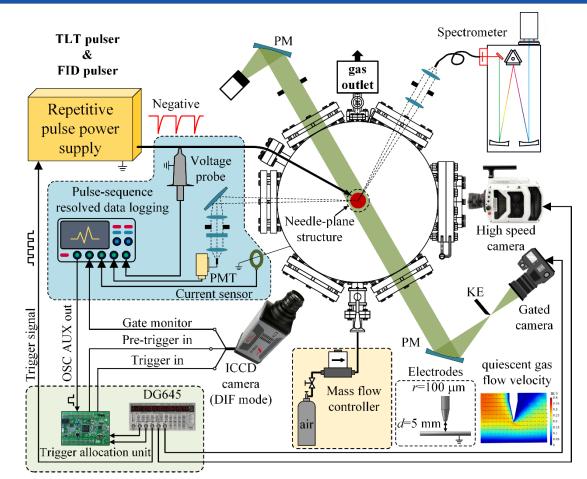
02 Discharge instability coupled with pulsed power supply

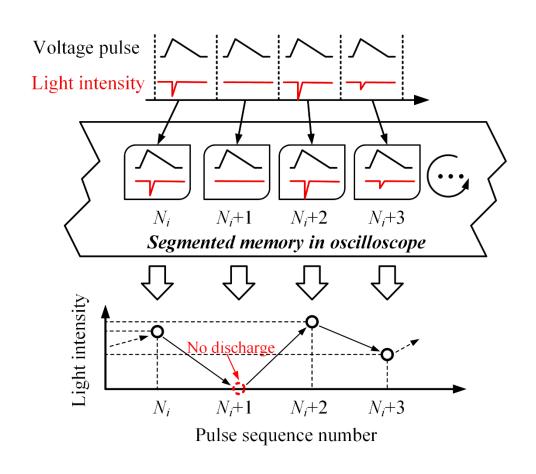
03) Discharge instability affected by gas flow

04) Concluding remarks

Experiment setup: pulse sequence resolved

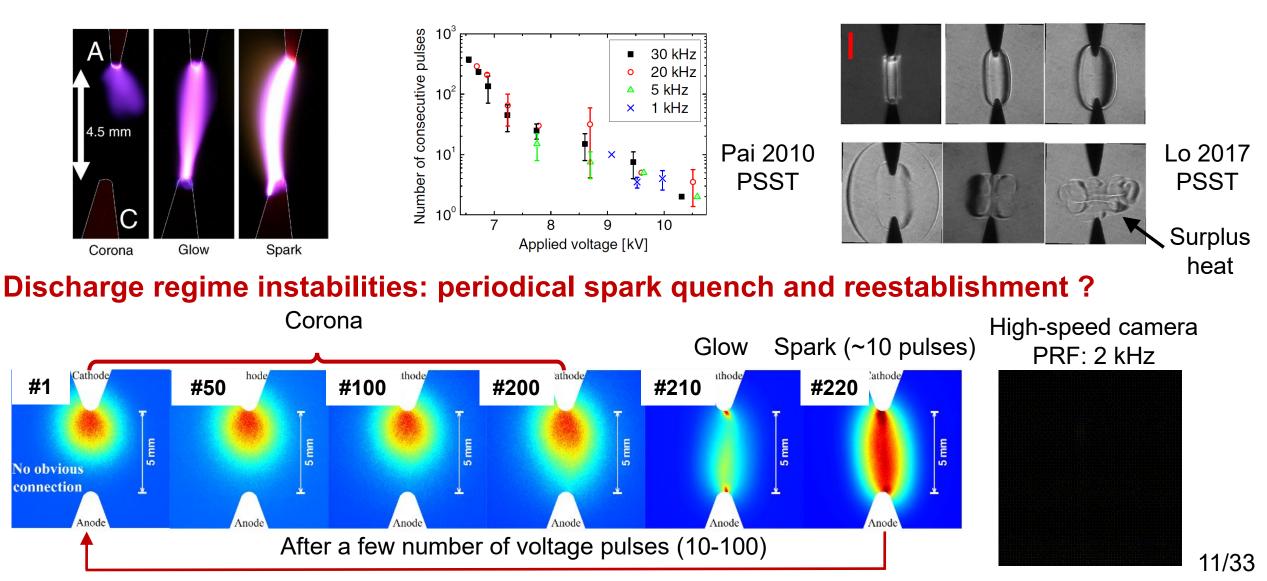
Electrical and optical diagnostics: voltage/current waveforms, emission light intensity ICCD images: temporally and pulse-sequence resolved images Data logging method: sequence mode for pulses with extremely low duty cycle





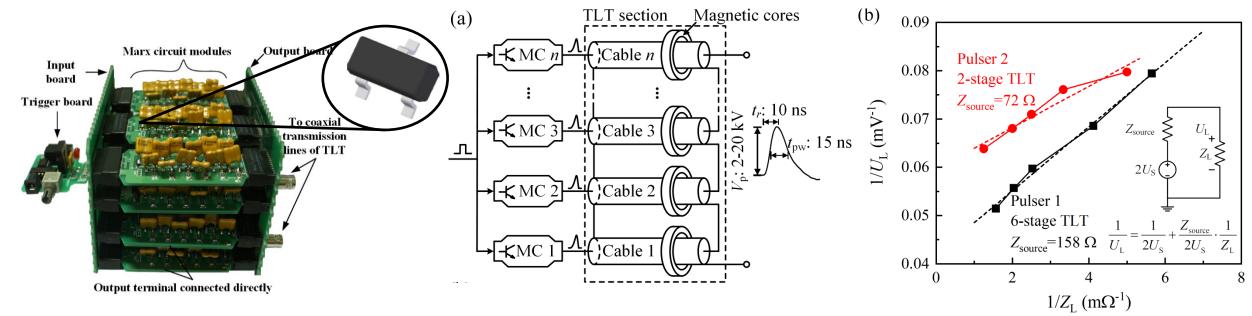
Main finding: Spark discharge disappears periodically

Conventional development pattern: enhancing transition pattern and no reversion



Repetitive nanosecond pulse power supply

Avalanche transistor Marx circuits + Transmission line transformer (power combining)



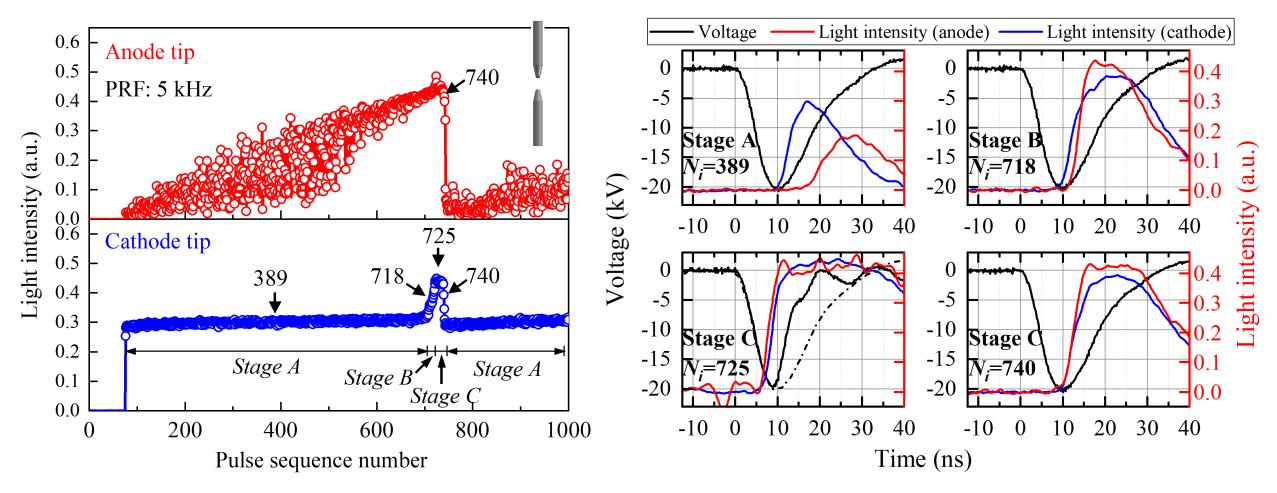
Output specifications of two pulse suppliers

	Power	Amplitude	Rise	Pulse	Output	Energy
į	supply	/kV	time/ns	width/ns	impedance/ Ω	storage/mJ
	Pulser 1	20	10	14	158	6.48
	Pulser 2	15.3	11	17	72	6.18
1	·/				·	

[1] Li J, Zhao Z, et al 2017 RSI **88** 033507 [2] Li J, Zhao Z, et al 2017 RSI **88** 093514

NRP discharge behaviors: needle-needle structure

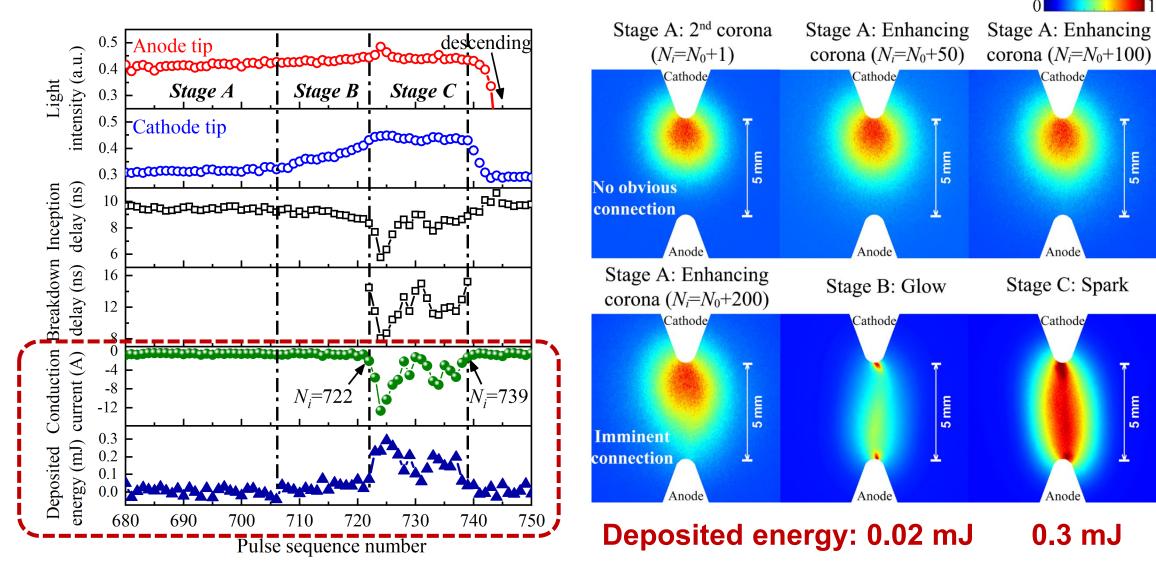
Periodical discharge regime transition (5 kHz)—electrical features



Pulser 1 (20 kV), needle-needle, $r/d=500 \mu m/5 mm$, 0.1 MPa N₂

NRP discharge behaviors: needle-needle structure(cont.)

Periodical discharge regime transition (5 kHz)—discharge channels

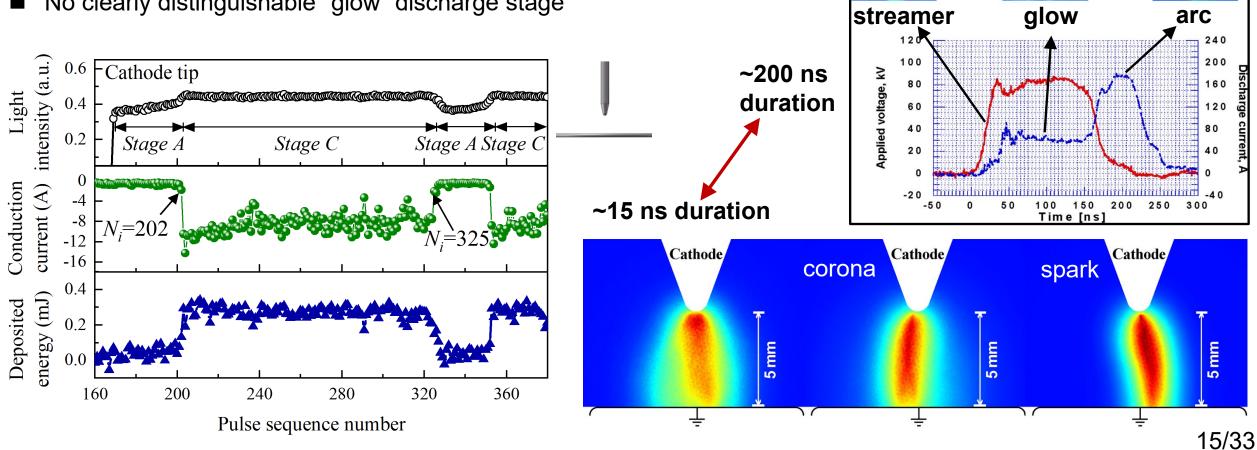


NRP discharge behaviors: needle-plane structure

Periodical discharge regime transitions in needle-plane structure (negative pulse)

- Spark regime could be sustained under much more voltage pulses
- Longer duration length of corona stage
- No clearly distinguishable "glow" discharge stage

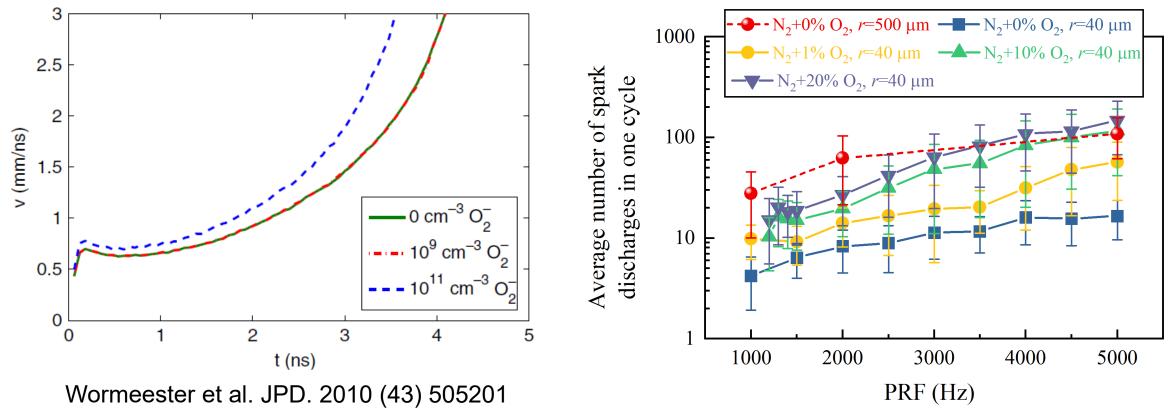
Wang DY et al. PSST. 2020 (29) 023001



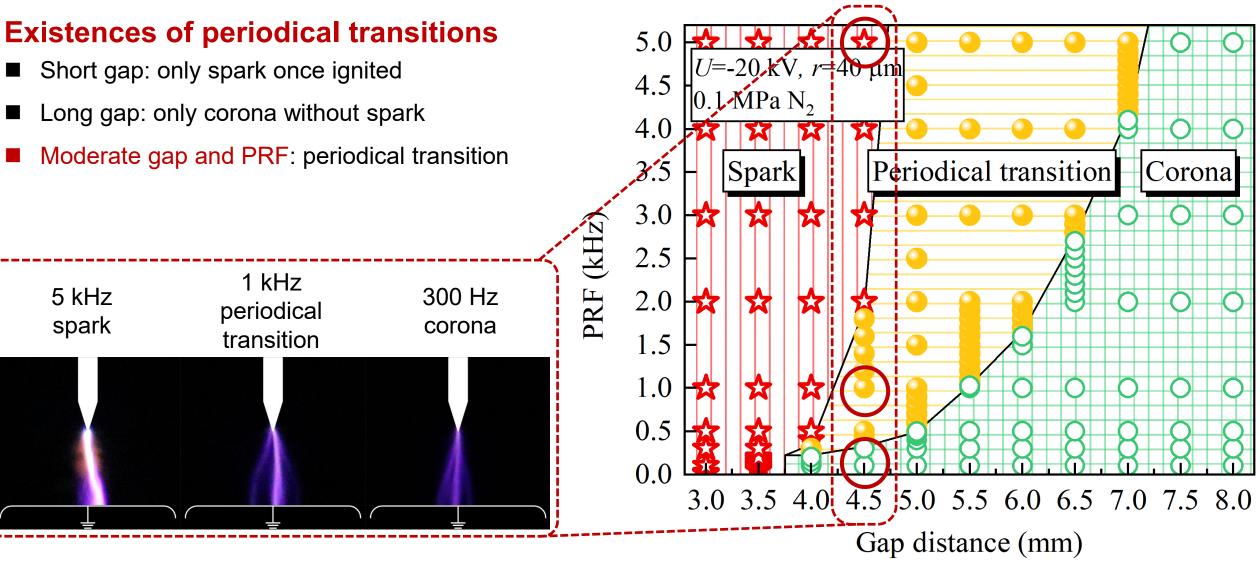
NRP discharge behaviors: effect of O₂ concentration

Effect of O₂ addition on discharge regime transition (negative pulse)

- Macroscopic changes: higher breakdown voltage, higher propagation velocity, branching features
- Microscopic mechanisms: electron attachment, photo-ionization, heating efficiency
- For discharge regime transition: longer spark regime, periodical transitions still exist

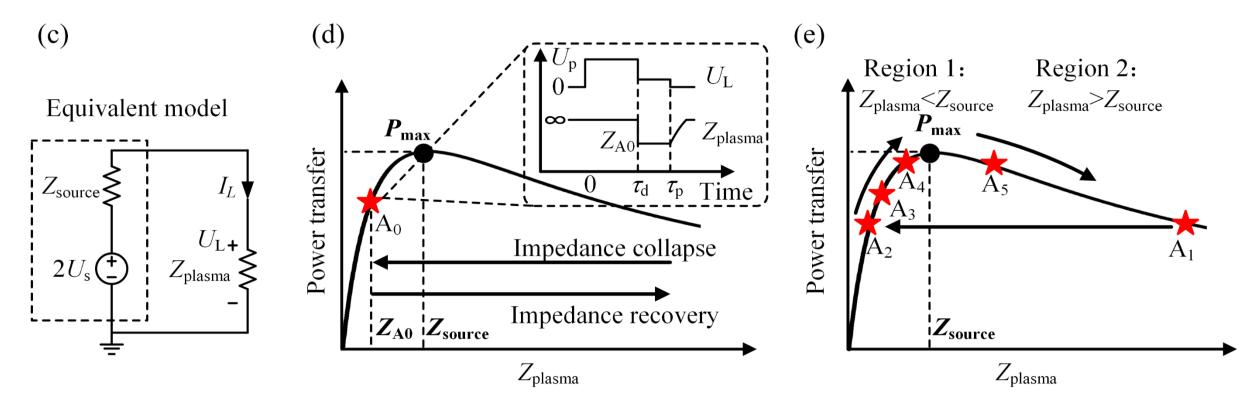


NRP discharge behaviors: parameter dependences



Plasma-source coupling

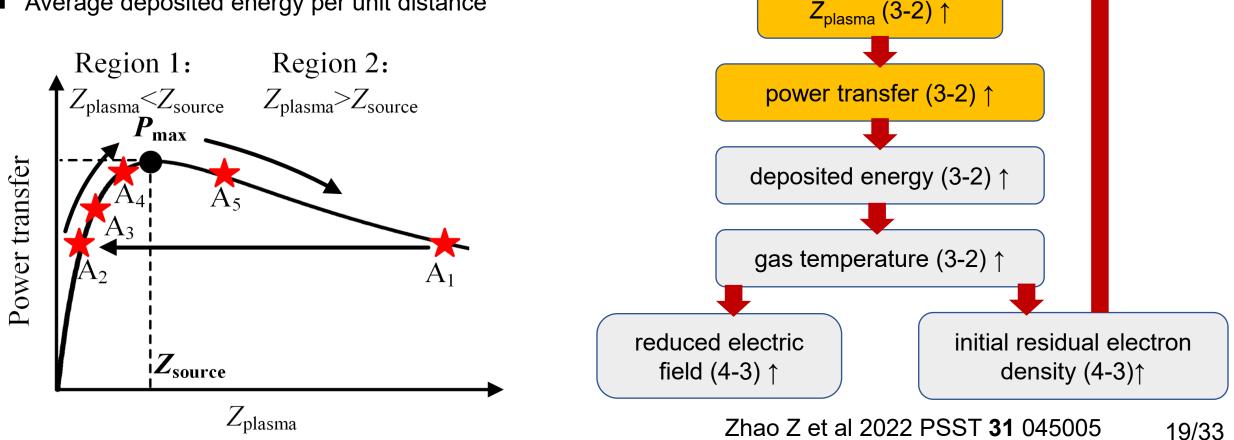
- Thevenin's equivalent circuit + Equivalent operation point (EOP)
- Movement of EOP during the discharge regime transition ("memory effect")



Periodical discharge regime transition mechanisms (2/3)

Plasma-source coupling (cont.)

- Multiple feedback mechanisms
- Effect of residual conductivity
- Average deposited energy per unit distance

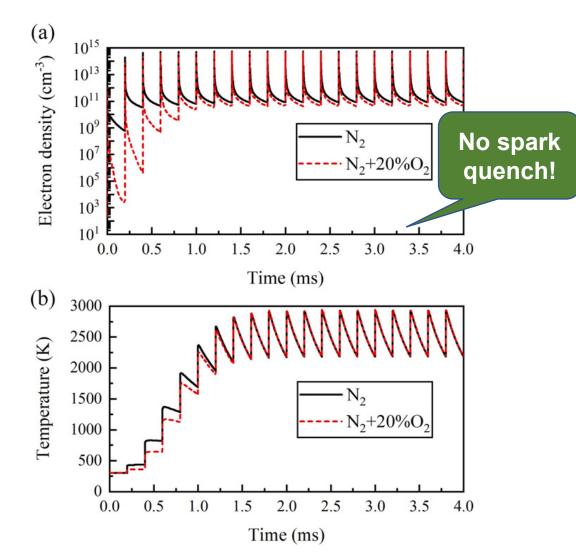


Feedback mechanism (among successive spark events)

initial residual electron density $(3-2) \downarrow$

Periodical discharge regime transition mechanisms (3/3)

Simple modelling with ZDPlasKin



Stability indicator based on enthalpy balance

$$\Gamma_{\rm eq} = \frac{\Delta H_{\rm input}}{\Delta H_{\rm relaxation}} = \frac{f_{\rm rep}\eta \int_{\tau_{\rm d}}^{\tau_{\rm p}} I_{\rm d}E\,{\rm d}t}{4\pi\lambda_{\rm avg}T_{\rm axis}} \left(\frac{r_{\rm T}}{r_{\rm ch}}\right)^2$$

$$\leq \frac{f_{\rm rep} W_{\rm max}}{d} \frac{\eta}{4\pi \lambda_{\rm avg} T_{\rm axis}} \left(\frac{r_{\rm T}}{r_{\rm ch}}\right)^2 \propto \frac{W_{\rm max}}{d \cdot 1/f_{\rm rep}}$$
$$W_{\rm max} = P_{\rm max}(\tau_{\rm p} - \tau_{\rm d}) = \frac{U_{\rm s}^2}{Z_{\rm source}}(\tau_{\rm p} - \tau_{\rm d}),$$

Based on Naidis G V 2008 JPD 41 234017

Γ_{eq} is estimated as 0.085 to 0.32 at 5 kHz (channel temperature is 1000-2000 K ?)

More instability mechanisms are required to be revealed!

Q1.Applicability of discharge mechanisms

Whether this peculiar transition pattern could only occur under the specific TLT pulser **or is prevalent** under other pulsers (commercially available FID pulser)?

Q2.Implicit straight streamer channel before quench

Streamer discharge evolutions that may lead to spark quenches have not been revealed.

Q3.Effect of additional gas flow

The enhanced residual *charge transport* and the *heat removal* would inevitably affect the discharge regime and transitions.



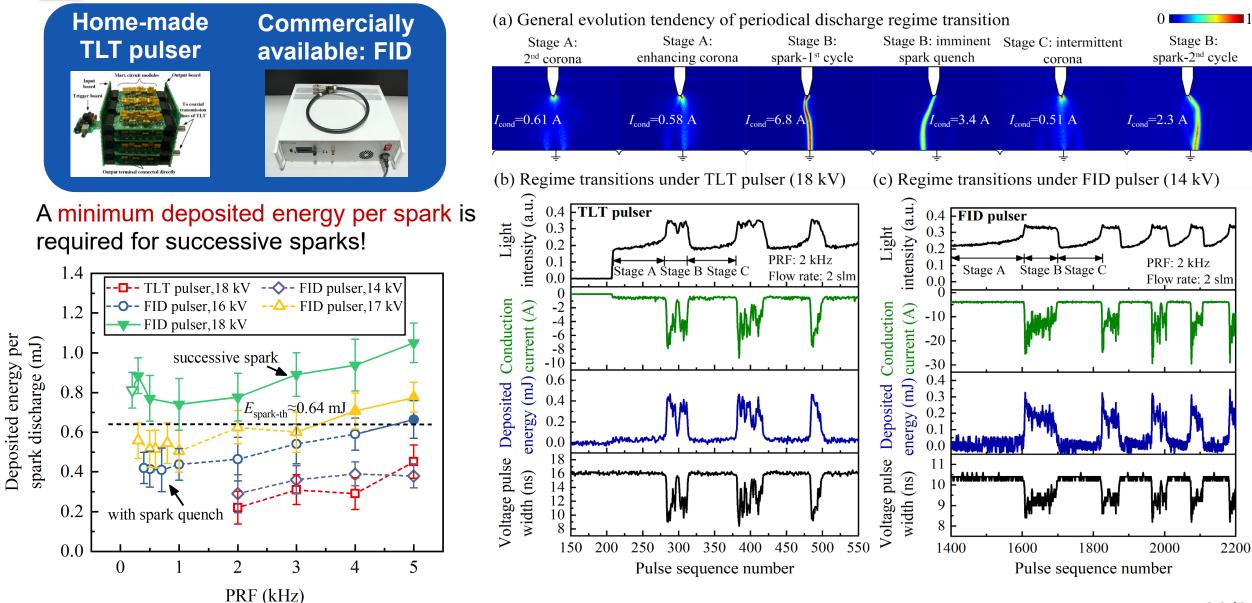
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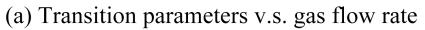
04) Concluding remarks

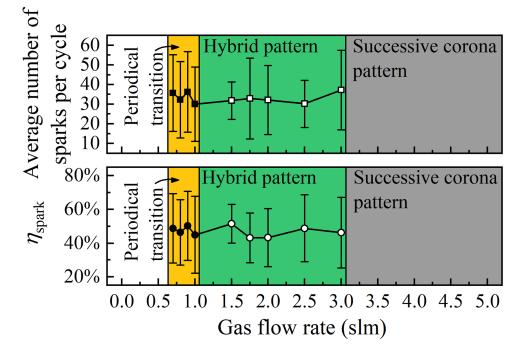
Comparisons of discharge regimes under two pulsers

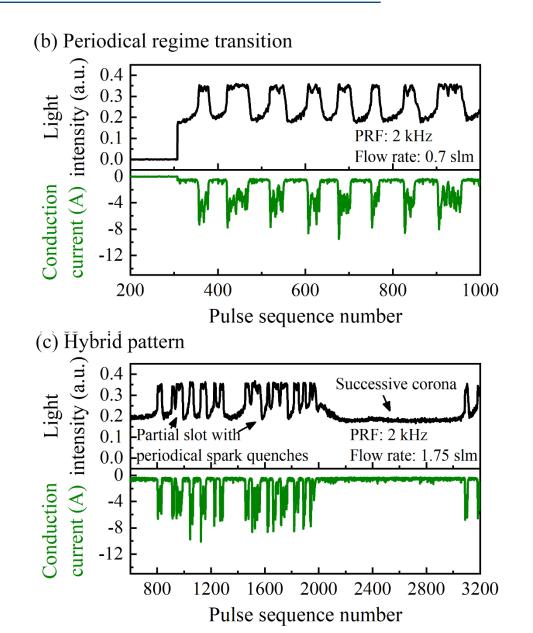


Effects of the gas flow: 1. gas flow rate

Periodical discharge regime transition ↓ Hybrid pattern ↓ Successive corona pattern





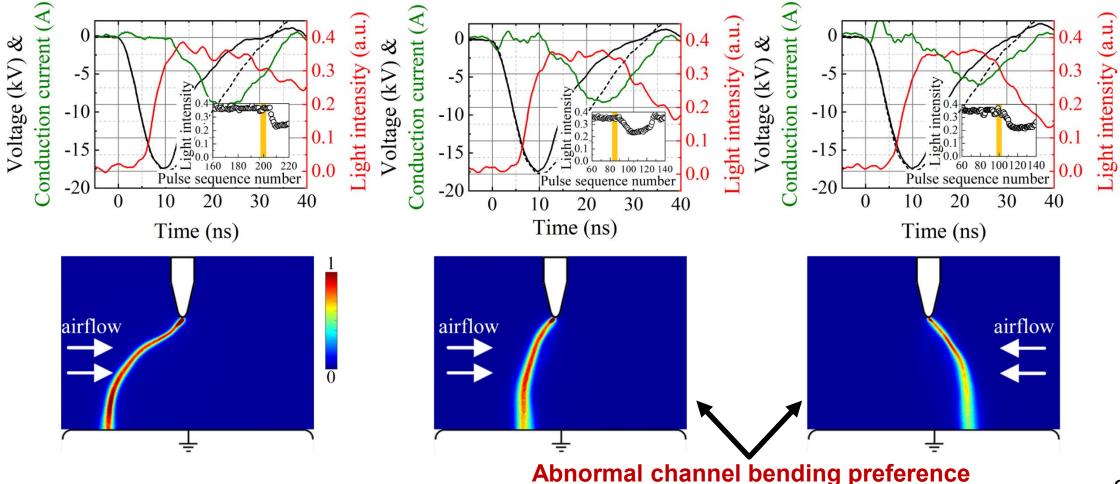


Effects of the gas flow: 2. gas flow direction

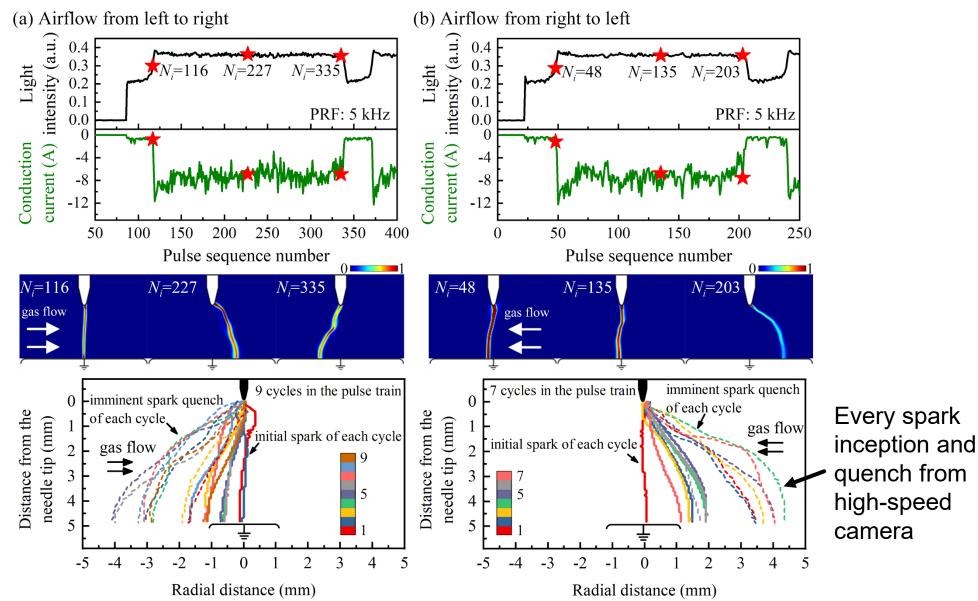
Abnormal channel bending preference: the spark prefers to bend upstream prior to the

its quench rather than downstream where high-density residuals are present.



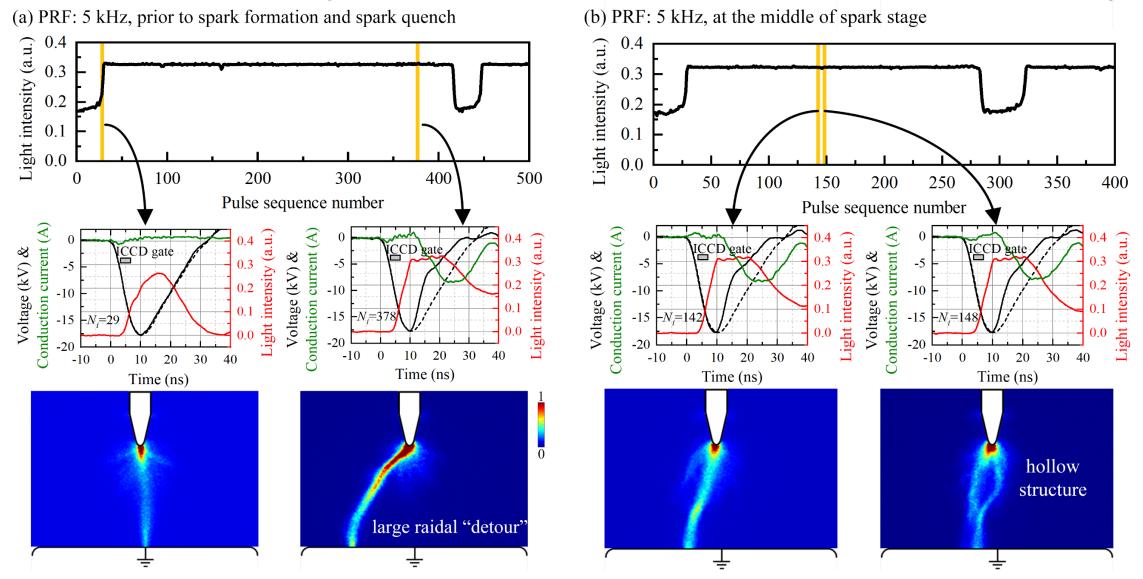


Effects of the gas flow: 2. gas flow direction (cont.)



Effects of the gas flow: 2. gas flow direction (cont.)

Streamer channel already bends before the spark quench: double frame feature (DIF)

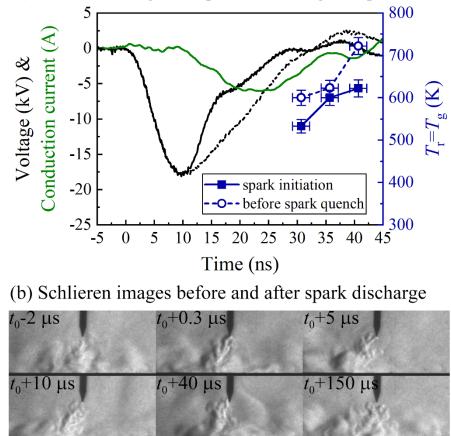


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Streamer dynamics before NRP spark quench

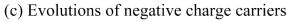
$$\frac{\eta_{\rm R}(T)W_{\rm total}f}{\pi d} = \alpha \lambda_0 (T - T_0)$$

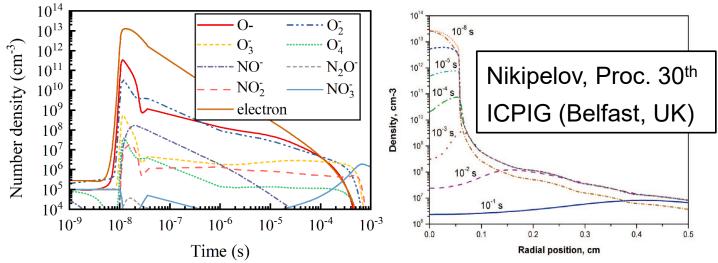
(a) Evolutions of gas temperature during the spark



Question1: why would the spark channel abnormally bend upstream rather downstream?

- Higher concentrations of residual negative ions at the upstream side
- Negative ions with higher electron bound energies would be formed and accumulated at the downstream side

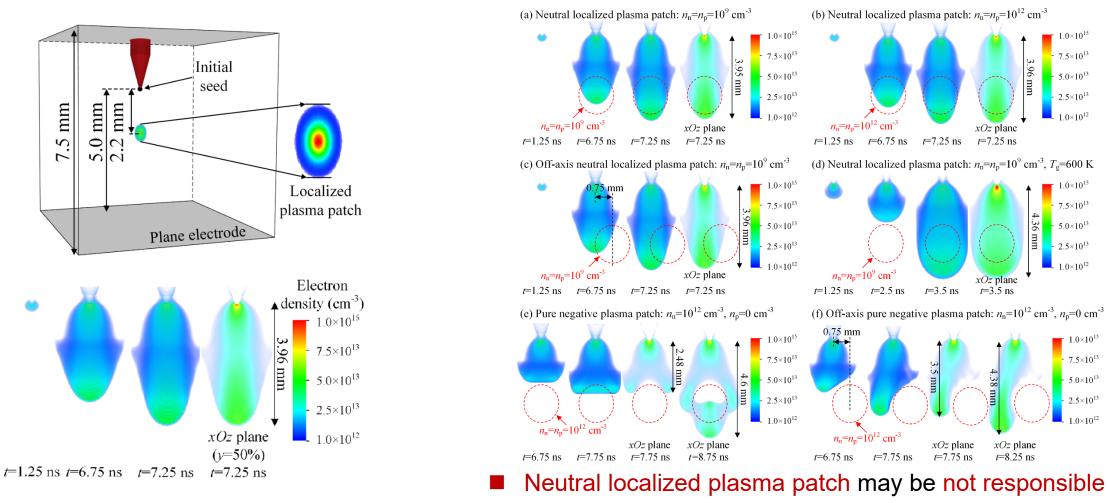




Streamer dynamics before NRP spark quench (cont.)

Question2: Are residual space charges responsible for the following streamer detour?

3D simulations of streamer propagation with different plasma patches



Afivo-streamer 3D

for the streamer "detour (still questionable!)



01) Background

02 Discharge instability coupled with pulsed power supply

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04 Concluding remarks



- Discharge instabilities exist in ~15 ns NRP streamer discharge, although discharge stochastics have been greatly weakened by residuals.
- Two fundamental discharge instability mechanisms: residual charge transport/energy relaxation (plasma modulation and scale-up).
- Evolutions of residual charges and strong coupling with pulsed power supply are important for NRP streamer instability development.

Related recent publications

- Zhao Z, Li C, Guo Y, et al. Streamer dynamics and periodical discharge regime transitions under repetitive nanosecond pulses with airflow[J]. *Plasma Sources Science and Technology*, 2023, 32 (1): 015002.
- 2. Zhao Z, Li C, Zheng X, et al. Periodical discharge regime transitions under long-term repetitive nanosecond pulses[J]. *Plasma Sources Science and Technology*, 2022, 31 (4): 045005.
- Zhao Z, Huang Z, Zheng X, et al. Evolutions of repetitively pulsed positive streamer discharge in electronegative gas mixtures at high pressure[J]. *Plasma Sources Science and Technology*, 2022, 31 (7): 075006.
- **4.** Zhao Z, Li J. Repetitively pulsed gas discharges: memory effect and discharge mode transition[J].
 High Voltage, 2020, 5 (5): 569-582.
- Zhao Z, Huang DD, Wang YN, et al. Volume and surface memory effects on evolution of streamer dynamics along gas/solid interface in high-pressure nitrogen under long-term repetitive nanosecond pulses[J]. *Plasma Sources Science and Technology*, 2020, 29 (1): 015016.



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- > The authors acknowledge Dr. Yifei Zhu for fruitful discussions and simulations by Mr. Yulin Guo.

Thanks for your attention!

Dr. Zheng Zhao Xi'an Jiaotong University Email: zhaozhengz@xjtu.edu.cn